Search Notes



Application/Control No.	Applicant(s)/Patent und Reexamination	er
10/767,770	OGAWA, HIDEHIKO	
Examiner	Art Unit	
Thomas D. Lee	2625	

SEARCHED				
Class	Subclass	Date	Examiner	
358	1.15, 402, 440	9/28/2005	TDL	
379	100.01	9/28/2005	TDL	
379	100.08	9/28/2005	TDL	
379	100.13	9/28/2005	TDL	
379	100.17	9/28/2005	TDL	
updated		3/31/2006	TDL	
updated		8/18/2006	TDL	

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	

SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
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